



Image AF/1765

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JOYCE S. OEY HEWETT
ALEXANDER J. PASADYN

Serial No.: 09/909,112

Filed: July 19, 2001

For: USE OF SLURRY WASTE
COMPOSITION TO DETERMINE THE
AMOUNT OF METAL REMOVED
DURING CHEMICAL MECHANICAL
POLISHING, AND SYSTEM FOR
ACCOMPLISHING SAME

Examiner: Lynette T. Umez Eronini

Group Art Unit: 1765

Att'y Docket: 2000.089100/TT4642

Customer No.: 23720

RESPONSE TO FINAL OFFICE ACTION DATED JANUARY 8, 2004

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

January 28, 2004
Date

Mary Paul
Signature

This paper is submitted in response to the Final Office Action dated January 8, 2004, for which the three-month date for response is April 8, 2004.

No fees are believed to be due in connection with the present paper. However, if any fees are due, the Director is authorized to deduct such fees required under 37 C.F.R. §§ 1.16 to 1.21 from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT4642. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.089100.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.